Supporting Information for:

Nanocrystal Formation and Polymorphism of Glycine

Xiaochuan Yang¹, Allan S. Myerson^{1,*}

1Department of Chemical Engineering, Massachusetts Institute of Technology

Patterns made by photolithograph and electron beam lithography:



Figure 1. The left image shows patterns of 500 nm and 1 μ m, while the right image exhibits enlarged patterns of 1 μ m.



Figure 2. Calculated XRPD patterns for glycine.